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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2815
Examiner: Jasmine Jhihan B. Clark

In Re PATENT APPLICATION Of:

Applicants: Takashi OHSUMI
Serial No.: 10/714,962
Filed: November 18, 2003
For: SEMICONDUCTOR DEVICE
Docket No.: OKI 389

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INFORMATION
DISCLOSURE
STATEMENT WITH
CERTIFICATION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This is an information disclosure statement submitted in compliance with the timing requirements of 37 C.F.R. §1.97(c), i.e., after a first Office Action on the merits but before Final Rejection and/or Notice of Allowance.

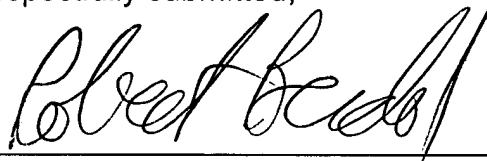
Attached are copies of two Japanese patent publications. The Examiner may also wish to consider the U.S. counterpart patents of these cited Japanese patent publications, and from which any relevance of the Japanese patent publications may be gleaned. U.S. patent No. 6,573,584 B1 corresponds to Japanese patent publication No. JP2001-185444, and the U.S. patent No. 6,441,487 B2 corresponds to Japanese patent publication No. JP2001-521288. The Japanese patent publications were first cited in a Japanese Office Action that was issued by the Japanese Patent Office in connection with a Japanese counterpart application. The publications are listed on the attached Form PTO-1449.

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It is hereby certified that each item of information contained in the Information Disclosure Statement was first cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this Information Disclosure Statement.

Consideration of the listed documents is respectfully requested.

Respectfully submitted,



July 14, 2004
Date

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RHB:vm



FORM PTO-1449 INFORMATION DISCLOSURE STATEMENT				Atty. Docket OKI 389		Application No. 10/714,962	
				Applicant Takashi OHSUMI			
				Filing Date November 18, 2003		Group 2815	
U.S. PATENT DOCUMENTS							
Examiner Initial		Document Number	Date	Name	Class	Sub-Class	Filing Date
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
FOREIGN PATENT DOCUMENTS							
		Document Number	Date	Country	Class	Sub-Class	Trans-lation
	AI	JP2001-185444	07/06/01	JAPAN			USP 6,573,584
	AJ	JP2001-521288	11/06/01	JAPAN			USP 6,441,487
	AK						
	AL						
	AM						
	AN						
OTHER (Including Author, Title, Date, Pertinent Pages, etc.)							
	AO						
Examiner					Date Considered		
EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.							